

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Chungte W. Chen et al.
For: IMAGING POLARIMETER
SENSOR WITH ACHROMATIC
BEAM-SPLITTING POLARIZER

Date: 9/23/2003

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner of Patents
and Trademarks
Washington, D.C. 20231

Dear Sir:

The reference cited on the enclosed form PTO-1449, (copy of which is enclosed) may be material to the examination of the above-identified patent application. It is respectfully requested that the references be considered and made of record in the application identified above.

This Information Disclosure Statement is not to be construed as a representation that a search has recently been made, that additional information material to the examination of this application does not exist, or that this citation constitutes prior art.

Respectfully submitted,
Chungte W. Chen et al.



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INFORMATION DISCLOSURE CITATION
(Substitute for Form PTO FB A820)
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Serial No. Filed:

Applicant: Chungte W. Chen et al.

GAU: Examiner:

Attorney Docket No. PD-03W008

US PATENT DOCUMENTS

Examiner's Initials	Document No.	Date	Name	Class	Subclass	Filing Date
	4,671,660	6/87	Distl et al.			
	5,363,235	11/94	Kiunke et al.			

Examiner's Signature

Date Considered